



**ELECTRONIC COPY**

LG731583128  
Report verification at igi.org



September 4, 2025  
IGI Report Number **LG731583128**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MODIFIED MARQUISE STEP CUT**  
Measurements **18.61 X 10.85 X 6.37 MM**  
**GRADING RESULTS**  
Carat Weight **10.32 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

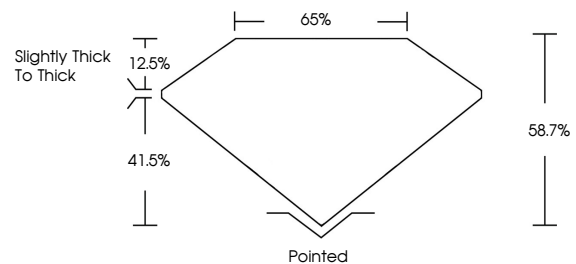
Carat Weight **10.32 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG731583128**

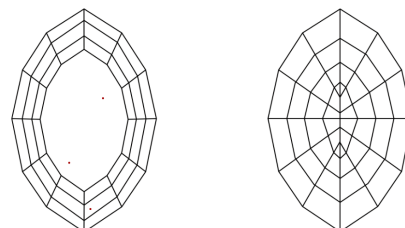
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

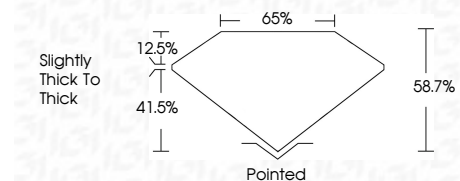
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**MODIFIED MARQUISE STEP CUT**  
**10.32 CARATS**  
Carat Weight **F**  
Color Grade **VVS 2**  
Depth **58.7%**  
Table **65%**  
Girdle **Slightly Thick To Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG731583128**  
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